

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Divakaruni et al.

Serial No.: 10/707,388

Filed: 12/10/2003

Title: SILICIDE RESISTOR IN BEOL
LAYER OF SEMICONDUCTOR
DEVICE AND METHOD

Conf. No.: 1387

Art Unit: 2891

Examiner: Fulk, Steven J.

Docket No.: FIS920030274US1
(IBMF-0032)

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

I. INTRODUCTORY COMMENTS:

In response to the Final Office Action of October 11, 2007, please amend the above-referenced patent application as follows: